



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2229

Applicants: Woo Sik Yoo
Assignee: WaferMasters, Inc.
Title: Method For Growing Oxide Film
Serial No.: 10/085,498 Filing Date: February 24, 2002
Examiner: Unassigned Group Art Unit: Unassigned
Docket No.: M-11549US

RECEIVED
OCT 31 2002
11-6-02
TC 2800 MAIL ROOM

Irvine, California
October 24, 2002

BOX IDS
COMMISSIONER FOR PATENTS
Washington, D. C. 20231

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Dear Sir:

Pursuant to 37 C.F.R. §1.97, Applicant wishes to call the following documents (copies enclosed) to the attention of the Examiner.

1. A PTO form 1449 listing these documents is enclosed.

Citation of the above documents shall not be construed as:

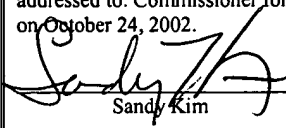
1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, or
3. an admission that the information cited herein is, or is considered to be material to patentability as defined in §1.56(b).

LAW OFFICES OF
MACPHERSON, KWOK CHEN
& HEID LLP

2402 MICHELSON DRIVE
SUITE 210
IRVINE, CA 92612
(949) 752-7040
FAX (949) 752-7049

Applicant(s) believes that no fee is required for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 50-2257. Please deduct any additional fees from, or credit any overpayment to the above-noted Deposit Account.

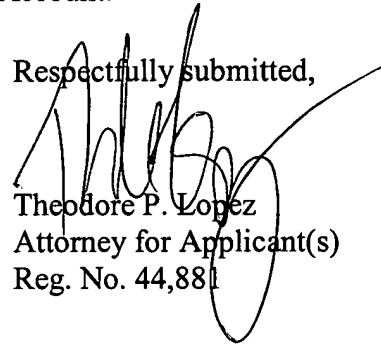
I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on October 24, 2002.



Sandy Kim

October 24, 2002
Date of Signature

Respectfully submitted,



Theodore P. Lopez
Attorney for Applicant(s)
Reg. No. 44,881

LAW OFFICES OF
MACPHERSON, KWOK CHEN
& HEID LLP

2402 MICHELSON DRIVE
SUITE 210
IRVINE, CA 92612
(949) 752-7040
FAX (949) 752-7049